

August 9, 2001



BOX PATENT APPLICATION Commissioner for Patents Washington, D.C. 20231

Re:

Application of Hiroyuki NAGASAWA

SILICON CARBIDE AND METHOD OF MANUFACTURING THE SAME

Assignee: HOYA CORPORATION

Our Ref. Q65781

Dear Sir:

Attached hereto is the application identified above including 37 sheets of the specification, including the claims and abstract, 6 sheet(s) of drawings, executed Assignment and PTO 1595 form, and executed Declaration and Power of Attorney. Also enclosed is the Information Disclosure Statement.

The Government filing fee is calculated as follows:

Total claims	19 - 20	=	X	\$18.00 =	\$.00
Independent claims	3 - 3	=	_ x	\$80.00 =	\$.00
Base Fee			_		\$710.00

TOTAL FILING FEE\$710.00Recordation of Assignment\$40.00TOTAL FEE\$750.00

Checks for the statutory filing fee of \$710.00 and Assignment recordation fee of \$40.00 are attached. You are also directed and authorized to charge or credit any difference or overpayment to Deposit Account No. 19-4880. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 and any petitions for extension of time under 37 C.F.R. § 1.136 which may be required during the entire pendency of the application to Deposit Account No. 19-4880. A duplicate copy of this transmittal letter is attached.

Priority is claimed from August 10, 2000 based on JP Application No. 242171/2000. The priority document(s) will be filed at a later date.

By:

Respectfully submitted, SUGHRUE, MION, ZINN, MACPEAK & SEAS, PLLC

Attorneys for Applicant

Alan J. Kasper

Registration No. 25,426